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CONFIRMATION NO. 3483

Bib Data Sheet

SERIAL NUMBER 10/612,074	FILING DATE 07/03/2003 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. P68962US0
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APPLICANTS

Jae Han Cha, Cheongjoo-Shi, KOREA, REPUBLIC OF;

** CONTINUING DATA *****

none ME

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2002-68052 11/05/2002

ME

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 09/29/2003

Foreign Priority claimed

☒ yes ☐ no

35 USC 119 (a-d) conditions met

☒ yes ☐ no ☐ Met after

Verified and Acknowledged

Examiner's Signature

Initials

STATE OR

COUNTRY
KOREA,
REPUBLIC
OF

SHEETS

DRAWING
2

TOTAL

CLAIMS
15

INDEPENDENT

CLAIMS
2

ADDRESS

00136
JACOBSON HOLMAN PLLC
400 SEVENTH STREET N.W.
SUITE 600
WASHINGTON, DC
20004

TITLE

Method of forming an isolation film in a semiconductor device

FILING FEE

FEES: Authority has been given in Paper
No. _____ to charge/credit DEPOSIT ACCOUNT
No. _____ for following:

☐ All Fees☐ 1.16 Fees (Filing)☐ 1.17 Fees (Processing Ext. of time)

h e ee b b f